

Docket No.: 2901653.11
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Charlotte Pham et al

Application No.: 10/553,654

Filed: October 14, 2005

For: USE OF SILICON CARBIDE-BASED
CERAMIC MATERIAL IN AGGRESSIVE
ENVIRONMENTS

Confirmation No.: 7452

Art Unit: n/a

Examiner: n/a

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INFORMATION DISCLOSURE STATEMENT (IDS)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sirs:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

A copy of the International Search Report from the parent application is enclosed.

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

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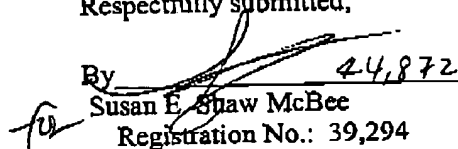
Docket No.: 2901653.11

It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

Applicant believes no fee is due with this submission. However, if a fee is deemed necessary, please charge our deposit account no. 11-0553 under order number 2901653.11, from which the undersigned is authorized to draw.

Dated: August 4, 2006

Respectfully submitted,

By  44,872

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PTO/SB/058/b (07-06)

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Substitute for form 1449A/B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Complete if Known			
		Application Number	10/553,654		
		Filing Date	October 14, 2005		
		First Named Inventor	Charlotte Pham		
		An Unit	n/a		
		Examiner Name	n/a		
Sheet	1	of	1	Attorney Docket Number	2901653.11

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U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	AA	5,580,809	10-01-1996	Cortellini	
	AB	5,474,587	12-12-1995	Dias et al	
	AC	2002/011683	01-31-2002	Gadkaree et al	
	AD	4,455,385	06-19-1984	Prochazka	
	AE	4,582,040	12-31-1985	Yamada et al	
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	AJ	6,342,269	01-29-2002	Yoshida et al	
	AK	4,952,533	08-28-1990	Hongu	

FOREIGN PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Foreign Patent Document Country Code ² -Number ³ -Kind Code ⁴ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	BA	EP-0356800	03-07-1990	Shinetsu Chemical Co	
	BB	FR-2806408	09-21-2001	Commissariat Energie Atomique	
	BC	WO-01/68560	09-20-2001	Commissariat Energie Atomique	
	BD	EP-511919	11-04-1992	Pechiney Electrometallurgie	
	BE	EP-1063210	12-27-2000	Ishikawajima Harima Heavy Ind	

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NON PATENT LITERATURE DOCUMENTS				
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue numbers), publisher, city and/or country where published.		
	CA	Qingwei, Huang et al, Microstructure of Reaction-Bonded Silicon Carbide, Feb, 2002 (XP-002264185)		

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Examiner Signature	Date Considered
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